

Notice of References Cited		Application/Control No. 10/050,570	Applicant(s)/Patent Under Reexamination YAGI ET AL.	
Examiner Matthew J Song		Art Unit 1765	Page 1 of 1	

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-4,855,254	08-1989	Eshita et al.	117/94
B	US-6,084,213	07-2000	Kohav et al.	219/390
C	US-5,759,908	06-1998	Steckl et al.	438/479
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K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Mogab et al. "Conversion of Si to epitaxial SiC by reaction with C2H2", Journal of Applied Physics, Vol 45, No 3, March 1974, pp 1075-1084.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.